



41

2881-

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of:

In-Kyeong YOO

Group Art Unit: 2881

Serial No. 09/865,607

Examiner: K. T. Nguyen

CIP of Serial No. 09/619,526,
Now U.S. Patent No. 6,476,402

Filed: May 29, 2001

Confirmation No. 4147

For: METHOD AND APPARATUS
FOR EMISSION LITHOGRAPHY
USING PATTERNED EMITTER

Atty. Docket No. 249/239

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents
United States Patent and Trademark Office
P.O. Box 1450
Alexandria, Va. 22313-1450

RECEIVED
OCT 15 2003
TECHNOLOGY CENTER 280C

INTRODUCTORY COMMENT

Sir:

In response to the Office Action mailed July 10, 2003, please consider the following remarks and amend the subject application as follows: